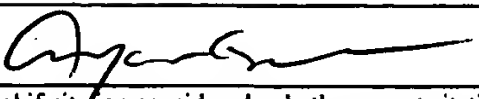


First Named Inventor	Kevin G. Donohoe	INFORMATION DISCLOSURE STATEMENT FORM PTO-1449
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Examiner Initials	Document No.	Issue/Publication Date	Name	Filing Date
TA	6,451,705B1	09/17/02	Trapp et al.	08/31/02
TA	6,565,721B1	05/20/03	Blalock et al.	10/09/97

Foreign Patent References					
Examiner Initials	Foreign Patent		Name	Publication Date	Translation
	Country	No.			

Other References	
Examiner Initials	Author, Title, Date, Pages, etc.

Examiner Signature		Date Considered	8/21/04
<small>*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>			